

**Search Notes**

Application/Control No.

09/714,267

Examiner

Chuck Kendall

Applicant(s)/Patent under  
Reexamination

MIMURA, TAKAYUKI

Art Unit

2192

**SEARCHED**

Class	Subclass	Date	Examiner
717	124-135	6/21/2005	CK
714	38	6/21/2005	CK

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
717	127-129	6/21/2005	CK
717	131	6/21/2005	CK
714	38	6/21/2005	CK

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East Search(USPAT,USPGPUB,IBM,DER WENT,JPO,EPO)	6/21/2005	CK
Google	06/21/05	CK
ACM	6/21/2005	CK
Consulted Wei XP 2192, Concurred with Allowable subject matter	6/21/2005	CK